In re Application of: AKIHIRO KIMURA ET A

Docket No. 03560.003032.1

Application No.: 10/789,996

Examiner: P.H. Patel

Filed: March 2, 2004

Group Art Unit: 2829

Date: April 22, 2004

For: VOLTAGE-APPLYING PROBE, APPARATUS FOR MANUFACTURING ELECTRON SOURCE USING THE PROBE,

AND METHOD FOR MANUFACTURING ELECTRON SOURCE USING THE APPARATUS

MAIL STOP THE COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

No additional fee is required.

The fee has been calculated as shown below

		С	LAIM	S AS AMEN	<b>VDEI</b>	)		
	(2) CLAIMS REMAINING AFTER AMENDMENT		PRE	(4) HEST NO. VIOUSLY AID FOR		(5) RESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	* 10	MINUS	**	20	=	0	x \$9 \$18	0
INDEP. CLAIMS	* 2	MINUS	***	3	=	0	x \$43 \$86	0
Fee for Multiple Dependent claims \$145°/\$290							\$290	
				AL ADDITI				\$290

If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.

If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space. If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

	Verified Statement claiming small entity status is enclosed, if not filed previously.				
X	A check in the amount of \$_290.00 is enclosed.				
	Charge \$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.				
X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.				
	A check in the amount of \$ to cover the fee for a month extension is enclosed.				
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.				
X	Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.				
	Respectfully submitted,				
	Attorney for Applicants Registration No. 35, 345				
30 Ro New	PATRICK, CELLA, HARPER & SCINTO ockefeller Plaza York, New York 10112-3800 mile: (212) 218-2200				

Form #120

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## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)				
AKIHIRO KIMURA ET AL.	:	Examiner: P.H. Patel			
Application No.: 10/789,996		Group Art Unit: 2829			
Filed: March 2, 2004	: )				
For: VOLTAGE-APPLYING PROBE, APPARATUS FOR MANUFAC- TURING ELECTRON SOURCE USING THE PROBE, AND METHOD FOR MANUFACTURING ELECTRON SOURCE USING	; ; ; ;				
THE APPARATUS  Mail Stop Commissioner for Patents P.O. Box 1450	)	April 22, 2004			
Alexandria, VA 22313-1450					

## SECOND PRELIMINARY AMENDMENT

Sir:

Preliminary to examination, please amend the above-identified application, filed herewith, as follows. The changes to the claims are reflected on the listing that begins on page 2, and the Remarks begins on page 4.

04/26/2004 FFRMREIA 00000010 10789996

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